



IFW
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date June 2, 2006

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 2812

Application No.: 10/722,422

Examiner: S. GEYER

Filed: November 28, 2003

Docket No.: 117897

For: METHOD OF MANUFACTURING CERAMIC FILM, METHOD OF MANUFACTURING FERROELECTRIC CAPACITOR, CERAMIC FILM, FERROELECTRIC CAPACITOR, AND SEMICONDUCTOR DEVICE

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

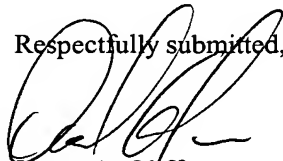
Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired May 2, 2006, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 180443 in the amount of \$120.00 in payment for:

<u>x</u>	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
<u> </u>	Extension fee for response within second month pursuant to §1.136(a) (\$450.00)
<u> </u>	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

06/05/2006 JADD01 00000022 10722422
01 FC:1251

Daniel A. Tanner, III
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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
